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Applicant: Yvon Gris et al.  
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For: METHOD OF DEPOSITION OF A SINGLE-CRYSTAL  
SILICON REGION  
Examiner: Matthew J. Song  
Art Unit: 1765

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CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 23<sup>rd</sup> day of July, 2003.

Signature

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR THREE MONTH EXTENSION OF TIME**

A three (3) month extension of time, to and including July 23, 2003, is requested for response to the Patent Office Communication of January 23, 2003.

The Commissioner is hereby authorized to charge the extension fee of \$930.00 as set forth in 37 C.F.R. §1.17(a) to Deposit Account No. 23/2825. Please charge any additional fees or credit overpayment to Deposit Account No. 23/2825. A duplicate of this sheet is enclosed.

Respectfully submitted,  
*Yvon Gris et al., Applicant*

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